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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/553,235	10/14/2005	Nobukazu Ikeda	SUGI0157	1287
24203 7590 04/27/2007 GRIFFIN & SZIPL, PC SUITE PH-1			EXAMINER	
			PATEL, HARSHAD R	
2300 NINTH S ARLINGTON,	STREET, SOUTH . VA 22204		ART UNIT	PAPER NUMBER
,	,		2855	
			DELIVERY	VMODE
SHORTENED STATUTOR	RY PERIOD OF RESPONSE	MAIL DATE	DELIVERY MODE	
3 MO	NTHS	04/27/2007	PAPER	

Please find below and/or attached an Office communication concerning this application or proceeding.

If NO period for reply is specified above, the maximum statutory period will apply and will expire 6 MONTHS from the mailing date of this communication.

TH

	Application No.	Applicant(s)			
	10/553,235	IKEDA ET AL.			
Office Action Summary	Examiner	Art Unit			
	Harshad Patel	2855			
The MAILING DATE of this communication a Period for Reply	appears on the cover sheet with the	correspondence address			
A SHORTENED STATUTORY PERIOD FOR REI WHICHEVER IS LONGER, FROM THE MAILING - Extensions of time may be available under the provisions of 37 CFR after SIX (6) MONTHS from the mailing date of this communication If NO period for reply is specified above, the maximum statutory peri - Failure to reply within the set or extended period for reply will, by sta Any reply received by the Office later than three months after the may earned patent term adjustment. See 37 CFR 1.704(b).	B DATE OF THIS COMMUNICATION 1.136(a). In no event, however, may a reply be tight of will apply and will expire SIX (6) MONTHS from the stute, cause the application to become ABANDONI	N. mely filed the mailing date of this communication. ED (35 U.S.C. § 133).			
Status					
1) Responsive to communication(s) filed on 20	0 April 2007.				
2a) This action is FINAL . 2b) ⊠ T	his action is non-final.				
3) Since this application is in condition for allow)☐ Since this application is in condition for allowance except for formal matters, prosecution as to the merits is				
closed in accordance with the practice unde	closed in accordance with the practice under Ex parte Quayle, 1935 C.D. 11, 453 O.G. 213.				
Disposition of Claims					
4) ⊠ Claim(s) 1-16 is/are pending in the application 4a) Of the above claim(s) is/are without 5) □ Claim(s) is/are allowed. 6) ⊠ Claim(s) 1-16 is/are rejected. 7) □ Claim(s) is/are objected to. 8) □ Claim(s) are subject to restriction and	drawn from consideration.				
Application Papers					
9) The specification is objected to by the Exam 10) The drawing(s) filed on is/are: a) a Applicant may not request that any objection to generate the second	accepted or b) objected to by the the drawing(s) be held in abeyance. So rection is required if the drawing(s) is o	ee 37 CFR 1.85(a). bjected to. See 37 CFR 1.121(d).			
Priority under 35 U.S.C. § 119					
12) Acknowledgment is made of a claim for fore a) All b) Some * c) None of: 1. Certified copies of the priority docum 2. Certified copies of the priority docum 3. Copies of the certified copies of the priority docum application from the International But * See the attached detailed Office action for a	nents have been received. Sents have been received in Applica priority documents have been receive reau (PCT Rule 17.2(a)).	tion No ved in this National Stage			
Attachment(s)					
1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO/SB/08) Paper No(s)/Mail Date S. Patent and Tradement Office	4) Interview Summal Paper No(s)/Mail (5) Notice of Informal 6) Other:	Date			

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Claim Rejections - 35 USC § 103

- 1. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 2. Claims 1, 3, 5, 9, 11, 14 and 16 are rejected under 35 U.S.C. 103(a) as being unpatentable over Inushima et al. (6,550,325) in view of Nagata et al. (5,291,781) (hereinafter Inushima or Nagata).

Inushima teaches a thermal type mass flow rate sensor comprising a substrate having a fluid contacting surface (Fig. 1B), a thin film forming a temperature sensor and a heater mounted on the rear face side of the fluid contacting surface of the substrate. Inushima does not teach a metal substrate. Nagata, in the same field of endeavor, teaches the use of a metal substrate (col. 4, lines 30-35). It would have been obvious to a skilled individual to use the metal substrate as taught by Nagata for the silicon substrate of Inushima since this are mere alternatives and that minor modifications can be made to accommodate the use of the metal substrate. As to a specific thickness of the metal substrate, it would be within the scope of the skilled individual to use a thickness that would be properly installed thus reducing the size and also for better thermal conductance. As to providing an insulating film or a protective film, such coatings are necessary to protect the components and the diaphragm of the sensor from environment it will be used in. A to fastening the base with the substrate, it is known in the art that a substrate may be welded or spot welded or soldered to the structure it needs to support on for stability. It does not require any specific skill for an individual in the area where it may require a special talent.

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3. Claims 2, 4, 6-8, 10, 12, 13 and 15 rejected under 35 U.S.C. 103(a) as being unpatentable over Inushima in view of Nagata and further in view of Azima (6,062,077).

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Inushima or Nagata does not teach the use of the sensor with a fluid controller with a specific structure as claimed. However, Azima teaches a thermal flow sensor coupled to a flow conduit and a fluid controller that has a sensor base having an inlet and an outlet and a body, wherein the body comprises a flow passage communicating with the inlet and outlet of the sensor base. It is inherent to provide a gasket when two elements are connected and that the fluid is being flown through it. It is within the skilled individual to use a specific type of gasket as long as it functions the same, i.e. to prevent leakage.

Response to Arguments

4. Applicant's arguments with respect to claims 1-16 have been considered but are moot in view of the new ground(s) of rejection.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Harshad Patel whose telephone number is (571) 272-2187. The examiner can normally be reached on Monday-Thursday (6:30 AM-5:00 PM).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Edward Lefkowitz can be reached on (571) 272-2180. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Harshad Patel Primary Examiner Art Unit 2855

HP 4/24/07